Attorney's Docket No.: 4733 USA D01/TCG/TPG/OTHE **Patent** Confirmation No.: 9641 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE n Re Application of: Steven Verhaverbeke et al. Examiner: Markoff, Alexander Application No: 10/616,093 Art Unit: 1746 Filed: July 8, 2003 For: ASSISTED RINSING IN A SINGLE WAFER CLEANING PROCESS Mail Stop RCE Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION ACCOMPANYING A REQUEST FOR CONTINUED EXAMINATION (RCE) Dear Examiner: In response to the Final Office Action mailed September 20, 2006, please enter the following amendments and consider the following remarks. A Request Continued Examination (RCE) is filed herewith. FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on:

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